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	Application No.	Applicant(s)	
	10/695,951	KIMURA ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Tianjie Chen	2627	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in the commetted of	n this application. If not included unication will be mailed in due course	e. THIS ne initiative
1. \boxtimes This communication is responsive to <u>Response filed on 09</u>	<u>9/19/2006</u> .		
2. 🔀 The allowed claim(s) is/are <u>6-9</u> .			
 Acknowledgment is made of a claim for foreign priority u a) All b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority do International Bureau (PCT Rule 17.2(a)). 	e been received. e been received in Applicati	on No	om the
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file MENT of this application.	e a reply complying with the requirem	ients
4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which giv			E OF
5. CORRECTED DRAWINGS (as "replacement sheets") mu	st be submitted.		
(a) I including changes required by the Notice of Draftsper		w (PTO-948) attached	
1) hereto or 2) to Paper No./Mail Date	<u>.</u> .		
(b) ☐ including changes required by the attached ExaminerPaper No./Mail Date	's Amendment / Comment o	r in the Office action of	
Identifying indicia such as the application number (see 37 CFR teach sheet. Replacement sheet(s) should be labeled as such in			of
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT 			ne .
Attachment(s)	.		
1. Notice of References Cited (PTO-892)		nformal Patent Application	
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	b. ☐ Interview S Paper No.	ummary (PTO-413), /Mail Date	
 Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date 	7. 🛭 Examiner's	Amendment/Comment	
 Examiner's Comment Regarding Requirement for Deposit of Biological Material 	8. 🛭 Examiner's	Statement of Reasons for Allowance	Э
	9. 🗌 Other	_·	
		Chin Joseph TIANJIE CHEN PRIMARY EXAMINE	e R

U.S. Patent and Trademark Office PTOL-37 (Rev. 08-06)

DETAILED ACTION

Priority

1. Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.

Election/Restrictions

2. Applicant's election without traverse of claims 6-9 in the reply filed on 09/19/2006 is acknowledged.

EXAMINER'S AMENDMENT

3. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

• Claims 1-5, 10-19 have been cancelled for they are restricted without traverse.

Reasons for Allowance

4. Claims 6-9 are allowed.

The following is an examiner's statement of reasons for allowance:

• With regard to independent claim, as the closest reference of record, Mackawa et al (US 6,935,014) discloses a method of fabricating a magnetic head including a single pole type head which includes a main pole 3 (Fig. 9, column 7, lines 42-46) and a return pole 10, the method including the steps of: forming a magnetic layer 3 (Fig. 3; column 6, line 11) which is processed to be the main pole; forming a first magnetic metal layer 5 (Fig. 3; column 6, line 20) and a non-magnetic insulator

layer 8 (Column 6, lines 42-44) in order on the magnetic layer; forming a first mask of a resist layer 9 (Column 6, line 39) on the non-magnetic insulator layer; shaping the non-magnetic insulator layer by reactive ion etching (Column 7, line 8-14), using the first mask, thus forming a second mask 10 (Figs 5-8); and shaping the magnetic layer into a designed shape of the main pole (Fig. 9), using the second mask; **but fails to show** that the metal layer 5 is a non-magnetic metal layer.

• Applicant asserts that this invention is a method to fabricate a magnetic head comprising a single pole type head suitable for narrow tracks, while preventing corrosion of the magnetic layer (Specification, p. 4).

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

5. The prior art made of record in PTO-892 Form and not relied upon is considered pertinent to applicant's disclosure.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tianjie Chen whose telephone number is 571-272-7570. The examiner can normally be reached on 8:00-4:30, Mon-Fri.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Hoa Nguyen can be reached on 571-272-7579. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

TIANJIE CHEN PRIMARY EXAMINER